

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L2	1	metal near gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask) and oxide with mask with (ald or atmic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:38			
2	BRS	L3	2	metal near gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:44			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Co mm en ts	Er ro r De fi ni ti on	Er ro rs
3	BRS	L1	26	metal near gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:40			
4	BRS	L4	2	metal with gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:44			
5	BRS	L5	3	metal and gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:45			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Co mm en ts	Er ro r De fi ni ti on	Er ro rs
6	BRS	L6	3	gate and ((oxide near mask with nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:46			
7	BRS	L7	5	((oxide near mask with nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:48			
8	BRS	L8	1	((oxide with mask and nitride near mask) or double near mask or dual near mask) with (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:49			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
9	BRS	L11	2	metal near gate and ((oxide with mask and nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:49			
10	BRS	L10	23	gate and ((oxide with mask and nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:49			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
11	BRS	L9	27	((oxide with mask and nitride near mask) or double near mask or dual near mask) and (ald or atomic adj layer adj deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/02 04:52			